

S/N 09/825,613

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Sujit Sharan et al.

Examiner: Asok K Sarkar

Serial No.: 09/825,613

Group Art Unit: 2891

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Title: METHOD FOR PECVD DEPOSITION OF SELECTED MATERIAL FILMS

AMENDMENT AND RESPONSE UNDER 37 CFR § 1.111

MSA Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

This paper responds to the Office Action mailed on July 3, 2006. Please amend the above-identified patent application as follows.

